Docket No.: OGOSH44USA

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.

10/566,116

Confirmation No. 3700

Applicant

Akihisa Inoue et al.

371 Filed

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January 24, 2006

Art Unit

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1793

Examiner

Weiping Zhu

Customer No.

00270

Title

00270

SPUTTERING TARGET AND METHOD FOR PRODUCTION

THEREOF

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE

Sir:

This is a timely Response submitted in reply to a non-final Office Action dated October 10, 2008. Monday, January 12, 2009 is the first business day of the U.S. Patent and Trademark Office following Saturday, January 10, 2009.

Remarks begin on page 2 of this paper.